

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional)	Application Number
	ELPIDA NEC03P103	
	Applicant(s)	WATANABE
	Filing Date	Group Art Unit July 16, 2003

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
144	2000-149588	30.05.2000	JAPAN (w/Abstract)	G11C	29/00		✓
	2000-030487	28.01.2000	JAPAN (w/Abstract)	G11C	29/00		✓
	11-017098	22.01.1999	JAPAN (w/Abstract)	H01L	25/00		✓
	09-091991	04.04.1997	JAPAN (w/Abstract)	G11C	29/00		✓
144	03-041538	22.02.1991	JAPAN (w/Abstract)	G06F	12/16		✓

OTHER DOCUMENTS (*Including Author, Title, Date, Pertinent Pages, Etc.*)

EXAMINER

Han Hwang

DATE CONSIDERED

1/7/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and no considered. Include copy of this form with next communication to applicant.